Acoustic tweezers via sub–time-of-flight regime surface acoustic waves

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Micrometer-scale acoustic waves are highly useful for refined optomechanical and acoustofluidic manipulation, where these fields are spatially localized along the transducer aperture but not along the acoustic propagation direction. In the case of acoustic tweezers, such a conventional acoustic standing wave results in particle and cell patterning across the entire width of a microfluidic channel, preventing selective trapping. We demonstrate the use of nanosecond-scale pulsed surface acoustic waves (SAWs) with a pulse period that is less than the time of flight between opposing transducers to generate localized time-averaged patterning regions while using conventional electrode structures. These nodal positions can be readily and arbitrarily positioned in two dimensions and within the patterning region itself through the imposition of pulse delays, frequency modulation, and phase shifts. This straightforward concept adds new spatial dimensions to which acoustic fields can be localized in SAW applications in a manner analogous to optical tweezers, including spatially selective acoustic tweezers and optical waveguides.

INTRODUCTION

Surface acoustic waves (SAWs) are an efficient tool for microscale manipulation in diverse applications, including optical scattering, waveguides and computing (1–5), telecommunications (6), sensing (7), and microscale manipulation (8, 9). A standing SAW field results in time-averaged nodal and antinodal positions on the substrate and fluids into which it couples and is readily generated on planar piezoelectric substrates by an AC signal applied to opposing sets of interdigital transducers (IDTs). However, this standing wave develops across the entire inter-IDT space, preventing localized manipulation in a manner analogous to optical tweezers. The term “acoustic tweezers” has been applied to microfluidic systems using SAW (10, 11), but the imposition of this field results in cell and particle patterning in the entirety of a microfluidic channel, although phased array bulk acoustic wave (BAW) transducers are capable of generating nonuniform acoustic patterns using several piezoelectric elements (12, 13). Here, we demonstrate the straightforward application of nanosecond-scale SAW pulses in a sub–time-of-flight (sub-TOF) regime, where the locations and dimensions of the localized standing wave regions in the substrate are determined by the TOF and pulse length of a SAW, and where only two sets of transducers are required. In recent work, Fourier synthesis has been used to shape the time-averaged substrate waveforms (14), although pulsed SAW has not been previously used to generate spatially localized standing wave patterning. The time-averaged field resulting from intersecting SAW pulses yields discrete standing wave locations in a coupled fluid independent of channel dimensions. This methodology uses conventionally fabricated IDTs on a piezoelectric/optical material—lithium niobate (LN, LiNbO3)—that is commonly used in optical waveguide and microfluidic applications. In contrast to SAW generated by pulsed lasers, this method presents a more conventional, easily used route for the generation of nanosecond-scale traveling SAW pulses without the need for optical equipment and permits the generation of high-amplitude substrate displacements for microfluidic manipulation.

SAW is profoundly useful for microscale manipulation because the length scale of the waves themselves is on the order of micrometers. Typical SAW wavelengths, 1 to 300 m, are generated using frequencies between 10 and 1000 MHz (16, 17). SAW is driven by conducting IDT structures on a piezoelectric substrate, where (at resonance) the mechanical displacements emanating from one set of finger pairs are reinforced by those from neighboring ones, with the resulting displacements maximized when f = c0/λSAW, where c0 is the sound speed in the substrate. Compared to BAW transducers (18–20), SAW is especially suitable for microfluidic applications because it is generated on a planar surface, is readily integrated with channel structures, and generates an acoustic field only in desired locations (17). These advantages have been used in SAW applications, including cell patterning (21), interfacial manipulation (22, 23), free surface translation (24, 25), atomization (26, 27), thin-film formation (27, 28), particle and cell separation (29–32), fluid pumping (33), localized heating (34, 35), and selective sorting (31, 36).

This work represents a substantial evolution of acoustic microfluidics, where standing wave–induced acoustic forces can be confined not only across the width of the transducers as in conventional SAW but also along the direction of propagation. This method takes advantage of the small, microsecond-order TOF over which a SAW will propagate from one set of transducers to the opposing set, with TOF = d/c0, where d is the characteristic distance over which a wave travels. When these IDTs are actuated by a pulse width with time tp less than this characteristic TOF, the width of the overlapping region (w) where the traveling waves emanating from each set of IDTs intersect is a subset of the total distance between them, with tp < d/c0 ≈ 2l. This principle is shown in the conceptual diagram in Fig. 1A and the sketch in Fig. 1B. Figure 1C shows an example of a completed device, where a polydimethylsiloxane (PDMS) channel is used to contain a fluid volume with suspended particles.

RESULTS

Our analytical models and numerical simulations of this TOF regime closely mirror one another. Figure 2 shows both the simulated and modeled traveling waveform (Fig. 2A) and the resulting time-averaged displacements (Fig. 2B) from the intersection of two of these
counterpropagating waves. The waveform shape of the propagating wave \( \xi(x) \) can be analytically modeled by calculating the contributions from each finger pair in the set of IDTs over the length of the SAW pulse, given by

\[
\xi_{\text{avg}}(x) = \begin{cases} 
\frac{x - w_1}{2} & \text{for } x = \left[ \frac{w_1}{2}, \frac{w_1}{2} + \frac{w_2}{2} \right] \\
1 & \text{for } x = \left[ \frac{w_1}{2} + \frac{w_2}{2}, \frac{w_1}{2} + \frac{w_2}{2} + \frac{w_3}{2} \right] \\
1 - \left( x + \frac{w_1}{2} - \frac{w_2}{2} \right) & \text{for } x = \left[ \frac{w_1}{2} + \frac{w_2}{2} + \frac{w_3}{2}, \frac{w_1}{2} + \frac{w_2}{2} + \frac{w_3}{2} + \frac{w_4}{2} \right]
\end{cases}
\]

where \( \xi_0 \) is the initial SAW displacement, \( w_1 = c_s T_p \) is the applied pulse width, \( w_2 = N w_{\text{SAW}} \) (both in units of length), and \( N \) is the number of finger pairs. The first and third terms account for the ramping regions on either end of the pulse, resulting from the incomplete resonance from a subset of the total number of finger pairs. The total pulse width \( w \) is equal to \( w = w_2 + w_3 \) (for \( w_2 > w_3 \)) due to the contributions from all IDT finger pairs, where \( w \) is at least as large as \( w_2 \). For \( w < w_2 \), the maximum displacement amplitude is given by \( \xi_{\text{max}} = w_2 w_3 \) shown by the green lines in Fig. 2A. The modeled time-averaged waveform shape is computed from the autocorrelation (self-intersection) of the transient modeled waveform, with \( \xi_{\text{avg}}(x) = \xi_{\text{avg}}(x)^* \xi_{\text{avg}}(x) \), and compares favorably to the simulated time-averaged displacement (Fig. 2B). Figure 2C demonstrates the sequence of stages in the development of a spatially localized intersecting SAW in full 3D simulation of a SAW emanating from opposing sets of IDTs on a piezoelectric LN substrate, including the initial generation, propagation, intersection, and continuous propagation after intersection. The maximum displacement amplitude at complete intersection for 57, 107, and 207 pulses are shown in Fig. 2D; note the graded amplitude decay at either end of this region, a feature that arises from the partial reinforcement of displacements for the initial few periods when more than one finger pair is used in a set of IDTs. It follows that the maximum amplitude is only reached for a given pulse when the pulse time exceeds the time required for a SAW to traverse the width of the IDTs. Figure 2A shows these effects, where, for a six-finger pair device, there are six local maxima before reaching maximum amplitude at the leading (and trailing) edges except for the case in which a pulse time of 57T is applied, in which case the steady-state maximum is never reached. That Eq. 1 is a good match for the simulation results in Fig. 2A, which emerge directly from applying an AC boundary condition to our electrodes on a simulated LN substrate, is a good verification of this model.

Figure 3A demonstrates the existence of discrete patterning locations in an experimental setup, actuated by opposing sets of six-finger pair IDTs (7-mm aperture) with a time-averaged applied power of 0.35 W (with a duty cycle of 0.1 and a period 10 times the pulse width). Figure 3A shows larger localized patterning regions for both longer pulse times and larger numbers of finger pairs, as expected from Eq. 1. Continuous SAW results in acoustic nodal positions throughout the width of the microfluidic channel (37–39), whereas pulsed nanosecond-scale actuation only results in particle patterning in the locations where the intersecting waves overlap (the localized standing wave region), leaving particles outside of this region largely unaffected. Graphs associated with each experimental image show predicted minimum displacement locations, corresponding to areas where 2-μm particles collect (MagSphere), where these analytical models incorporate the attenuation of the acoustic beam as it travels along the substrate/fluid interface and display the time-averaged displacement relative to that before exposure to the fluid. The dimensions of the predicted region compare favorably for smaller pulse lengths, although the observed patterning region is somewhat smaller than the full extent of the region for which a partial standing wave exists at longer pulse lengths. This illustrates the effect of acoustic attenuation arising from a water-loaded SAW: With an attenuation length of ~500 μm, the magnitude of each propagating 40-μm-wavelength SAW is reduced to 13% of the original one at the channel center and is less than 5% by the end of the predicted patterning region (at approximately \( y = 550 \mu m \) in the case of a 300-ns pulse). The dotted lines in Fig. 3A represent the condition where the local average displacement minima are less than 0.25ₜ₝₀.
which yields a consistent and reasonable match for the dimensions in which strong patterning occurs for the given applied power and channel dimensions used here. Although local minima exist outside this region, these prove insufficient for the purpose of producing strong and reproducible patterning phenomena, owing to the relative weakness of the local acoustic field. These patterning regions are demonstrated in a continuous flow in movie S4.

An important consideration in acoustic microfluidics is the influence of the traveling waves themselves on particle behavior. This is not a significant factor in this instance due to the size of the particles relative to that of the fluid wavelength. The reflections in the vicinity of the particle become increasingly directional and of larger magnitude with increasing particle dimensions, where the force scaling changes from an $F \sim R^6/c_s R^3$ relationship (depending on the viscosity of the surrounding medium (40)), where $F$ is the acoustic force and $R$ is the particle radius, to a more complex relationship as the particle size approaches the acoustic wavelength (41, 42). Although the size of the viscous boundary layer varies with fluid density and viscosity (43), which in turn influences the particle size at which the traveling wave forces become significant for the purposes of particle translation, this transition has been experimentally determined to occur in the vicinity of $\kappa \approx 1.3$ to 1.4 for polystyrene particles in water (44–46). Here, $\kappa = \pi d/\lambda_s$, where $d$ is the particle diameter and $\lambda_s$ is the wavelength in the fluid, yielding a maximum diameter ($d_{\text{max}}$) of 6 and 12 $\mu$m for the 40- and 80-$\mu$m wavelengths ($\lambda_{\text{SAW}}$), respectively, used in this work. The traveling wave force does not significantly modify particle positions below such dimensions, and particles will be translated toward the channel center at dimensions above these. For the 2- and 3-$\mu$m particles used in this work, these equate to $\kappa$ values of 0.4 and 0.6, respectively, which accordingly failed to demonstrate directional particle motions arising from the traveling wave force.

The development of the localized field is analyzed in Fig. 3B, which shows the mean fluorescence intensity of the particles as they are being patterned across the simulated region shown in Fig. 3C (see movie S1). The primary aggregation of particles occurs in the localized standing
Fig. 3. Experimental particle patterning actuated by continuous and sub-TOF regime pulsed SAW. (A) In contrast to conventionally applied acoustic fields, applying pulse lengths with $t_p < \text{TOF}$ results in the time-averaged standing wave locations only where the two incident waves overlap, here with $t_p = 50, 100, 200,$ and $300\text{ ns}$ (approximately $5T, 10T, 20T,$ and $30T$), driven by $40\mu m$ six-finger pair transducers at $96\text{ MHz}$, visualized with $2\mu m$ particles in a $2\text{ mm}$-wide channel after $5\text{ s}$ of pulsed excitation (time-averaged applied power $= 0.35\text{ W}$). These patterns correspond to the predicted patterning locations at time-averaged minimum displacement conditions, especially for smaller time-averaged minima (dotted lines correspond to conditions where $|x|$ minima are less than 0.2). Continuous patterning is demonstrated in movie S4. (B) During pattern development in a $1\text{ mm}$-wide channel, $3\mu m$ primary particle patterns result from the combination of the intersecting $100\text{ ns}$ pulsed traveling waves (between dotted lines). a.u., arbitrary units. (C) Mean intensity along the $x$ direction is assayed in the region (for $t = 10\text{ s}$) from movie S1. (D) The appearance of secondary near-field patterning [dash-dot boxes in (B)] results from diffraction in the vicinity of the acoustic impedance discontinuity at the channel wall boundary shown here. Scale bars, $200\mu m$. 

wave region, whereas secondary near-field patterning is observed to develop over longer time scales (dash-dot lines in Fig. 3B). We find that the emergence of this effect can be explained by the generation of time-averaged pressure amplitude patterns in the vicinity of the acoustic property discontinuity at the PDMS/fluid boundary (see Fig. 3D). This 2D numerical simulation, a video of which is shown in movie S2, models the solid/fluid acoustic interactions in a pulsed field. The spherical propagation of acoustic displacements in the vicinity of this interface according to the Huygens-Fresnel principle results in near-field diffraction and time-averaged regions of lower acoustic energy toward which particles will preferentially migrate (43), although the magnitude of these variations is less pronounced than that in the central patterning region, which has larger acoustic pressure gradients. This model (pictured at \( t = 41T \)) simulates the interaction of a SAW emanating from a six–finger pair set of IDTs actuated with a pulse lasting 10\( T \) (~100 ns) along a piezoelectric LN substrate and the effects of the PDMS domain at the channel periphery. The top surface of the fluid domain, the channel roof, is imposed with a PDMS impedance boundary condition, which is sufficient because the PDMS domain is much larger than the channel height, whereas the 50-\( \mu \)m PDMS walls are explicitly simulated. The effect of a physical PDMS boundary over the fluid domain is minimal, resulting in a small amount of reflection due to the fractional acoustic impedance difference between water and PDMS and thus a degree of acoustic patterning in the \( z \) direction, although the magnitude of this effect is secondary to that of primary patterning.

Patterning in the TOF regime is not limited to the generation of unitary localized standing wave fields. Figure 4 shows the generation of three separate time-averaged patterning regions by using a pulse period that is less than the amount of time the entire traveling wave pulse takes to traverse the width of the channel (here, a 75-\( \mu \)m pulse with a 200-\( \mu \)ns period was used, which is less than the 254-\( \mu \)m TOF + 75-\( \mu \)ns pulse length of the 1-mm channel). The instantaneous, analytically modeled, and interfering waves, as well as their time-averaged displacements, are shown in movie S3. The modeled minimum displacements in Fig. 4C correlate with the observed particle aggregation locations, measured from the mean fluorescence intensity in Fig. 4 (A and B). Here, the channel is displaced (90 \( \mu \)m vertically) from the midpoint between opposing transducers to demonstrate the independence of the patterning region from the channel dimensions; because the standing wave locations are substrate-bound, the patterning locations can be arbitrarily determined with respect to the channel.

In the cases examined so far, the patterning regions have been symmetrical about the midpoint between the opposing sets of IDTs: This is where counterpropagating waves intersect when each set of transducers is actuated simultaneously. However, the TOF-induced patterning regions can also be applied at arbitrary locations along the propagation direction by independently controlling the times at which each set of transducers is actuated. By applying a triggered delay to the 100-\( \mu \)s, 48-MHz pulse to one of two sets of 80-\( \mu \)m six–finger pair IDTs in a 3-mm-wide channel in Fig. 5A, we demonstrate that the patterning locations can be generated independently of the channel position on the SAW device. Here, the traveling SAW propagating along the \( x \) direction from the upper set of IDT’s generated hundreds of nanoseconds before and after that from the lower set, resulting in highly accurate patterning region shifts. Patterning localization can similarly be extended into the \( y \) direction by using a SAW device architecture where the acoustic wavelength varies across the IDT aperture. Figure 1C shows such a device, where \( \lambda_{SAW} \) varies between 40 and 80 \( \mu \)m, corresponding to resonant frequency conditions between 48 and 96 MHz (larger wavelengths correspond to lower frequencies). Applying 100-\( \mu \)s pulses at frequencies in this range results in localized patterning only where a SAW is produced, as shown in Fig. 5B, where the patterning region is shifted laterally along the device aperture for 55-, 65-, 75-, and 85-MHz frequencies (corresponding to wavelengths of 71, 60, 52, and 46 \( \mu \)m). However, the localization along the \( y \) direction (~1 mm) is not as discrete as that along the propagation direction (~100 \( \mu \)m) in this implementation, given the large device aperture (10 mm) and the small number of finger pairs (6) that result in a wide transmission bandwidth (47); the localization in this direction could be improved with larger numbers of finger pairs and/or larger wavelength gradients (using smaller apertures and/or wider frequency ranges), although as a trade-off, the width of the \( x \) direction patterning region would increase in line with Eq. 1 for an increasing number of finger pairs.

Although the extent of the patterning regions is on the order of 100 \( \mu \)m at a minimum for wavelengths on the order of tens of micrometers and thus by itself limits the application of these patterning regions for manipulation of individual particles or cells in concentrated solutions, this can be somewhat circumvented via the fine-grained control that is achievable within the patterning region itself, where phase shifts can result in translated time-averaged nodal positions (48, 49). Figure 5C demonstrates the shift in nodal positions with the application of a phase-shifted, 48-MHz, 100-\( \mu \)s pulse in a device with a \( \lambda_{SAW} \) of 80 \( \mu \)m. Applying a phase delay of \( \Delta \phi = 180^\circ \) results in an inversion of the nodal/antinodal positions compared to \( \Delta \phi = 0^\circ \), for example, and the gradual shift between these two cases results in total translation/nodal position differences that are smaller than the acoustic wavelength.

**DISCUSSION**

The effect of attenuation at the LN/water interface, which results from the transfer of energy from the solid substrate to the coupled fluid, with an attenuation length (over which the initial displacement amplitude decays to \( 1/e \) of its initial value) of 12.8 \( \lambda_{SAW} \) is yet to be discussed (31, 50). For the case tested, this means that each incoming 40-\( \mu \)m wave will have attenuated to approximately 38% of its initial value at the center of a 1-mm channel but approximately 14% at the center of a 2-mm channel. Not surprisingly, this attenuation has little effect on the expected nodal positions where particles aggregate for a smaller channel width but has considerable effect for larger channels. Note that patterning is demonstrated across the width of the 1-mm channel in Fig. 4A, whereas longer pulse lengths result in smaller-than-expected patterning regions for the wider channel in Fig. 3A. However, even a standing wave at a fractional value of its initial intensity should still eventually lead to particle migration, albeit at a lower rate. However, amplitude attenuation in the fluid itself presents a potentially more potent effect on particle translation, where the propagation of a high-frequency acoustic wave through a dispersive medium, such as water, generates a body force in the direction of propagation (50). This effect can be reduced by minimizing the body force gradients that give rise to acoustic streaming, at their strongest at the edge of the SAW beam, and reducing the channel height where appropriate (28, 51). Acoustic gradients can be ameliorated for patterning applications, as it has been in this work, by using channel widths smaller than the IDT aperture (3.2 and 3.6 mm for the 40-\( \mu \)m device in Fig. 3B). This is not necessarily required, where streaming is similarly not a noticeable concern even


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**Fig. 4. Generation of multiple discrete patterning regions.** (A) The application of a 75-ns pulse with a 200-ns period, which is less than the minimum time it takes for a complete wave to pass across the 1-mm channel (the channel’s 254-ns TOF plus the 75-ns pulse period), generates symmetric standing wave regions as visualized with patterned 3-μm particles. (B and C) The measured mean intensity across the width of the channel (B), corresponding to the predicted locations of minimum time-averaged displacement (C). Scale bar, 200 μm.

**Fig. 5. 2D patterning control.** (A) The patterning region in the direction of propagation (the x direction) can be arbitrarily determined through the imposition of a time-delayed pulse, where the pulse traveling from the top of the device is delayed by the value shown. (B) The patterning regions in the y direction (in dashed boxes) can similarly be modified using a SAW device whose wavelength changes along the y direction (here between 40 and 80 μm; device shown in Fig. 1C). All other results are for nonslanted IDT designs. (C) The patterning of nodal positions within the patterning region can also be shifted by imposing a phase shift $\Delta \phi$ to one of the opposing sets of transducers. All particles are 2 μm. Scale bars, 200 μm.
with the use of slanted-finger IDTs, as is the case in Fig. 5C, where the SAW beam width is smaller than that of the channel. This is partly due to the graded drop-off in displacement magnitude with this transducer type (52).

Given the wide range of activities that are already accomplished with SAW, the use of nanosecond-scale pulses to generate locality along the direction of propagation and across the width of the transducers represents a conceptually simple but significant evolution in the dexterity that is possible using microscale acoustic fields. Reducing the width of the region over which a standing wave is formed permits localized trapping in a manner more analogous to optical tweezers, leaving surrounding regions unaffected. Phase shifts between opposing transducers combined with the imposition of an additional orthogonal SAW allow for selective and fully 2D particle and cell manipulation. Moreover, given the wide use of SAW for optical and mechanical manipulation, the ability to further localize acoustic fields presents a new avenue for the fine-tuned generation of highly local SAW displacements.

**REFERENCES AND NOTES**


**Supplementary Materials**

Supplementary material for this article is available at http://advances.sciencemag.org/cgi/content/full/2/7/e1600089/DC1

movie S1. Development of localized acoustic patterning region.

movie S2. Numerical simulation of pulsed SAW, including 2D and 3D models of the piezoelectric substrate and a model of the acoustofluidic interaction.

movie S3. Analytical model of sub-TOF regime SAW.

movie S4. Generation of time-averaged localized patterning regions using 50-, 100-, 200-, and 300-ns pulses.

**Materials and Methods**

**Numerical simulation**

The numerical simulation was performed using COMSOL v5.0 (see Fig. 2, C and D). A time-dependent transient 2D model was used to simulate waveforms by applying an AC signal to regions representing the IDT finger pairs on a piezoelectric substrate. The stiffness, coupling coefficient, and electrical permittivity matrices were rotated to correspond to the 128°-cut x-propagating LN crystal used experimentally. The maximum mesh dimension was λ_{SAW}/10.

**SAW devices**

IDTs are composed of a conductive 200-nm Al or Au layer on a 7-nm Cr adhesion layer and patterned on a piezoelectric LN substrate using the lift-off process after evaporative metal deposition. The width of each metal strip is equal to λ_{SAW}/4, 10 μm for λ_{SAW} = 40 μm, 20 μm for λ_{SAW} = 80 μm, and linearly graded between 10 and 20 μm for the 40- to 80-μm slanted-finger IDT device. A finished device was produced by bonding a PDMS microchannel to the substrate after exposure to an air plasma (Harrick Plasma PDC-32G; 1000 mtorr, 18 W). This bonded microchannel (1 mm wide and 20 μm high, 2 mm wide and 40 μm high, or 3 mm wide and 60 μm high) incorporated an air channel over the IDTs and a small, 50-μm-thick PDMS wall between the air- and fluid-filled sections to minimize attenuation before the fluid channel. These devices were actuated with a signal generator (AnAPlco APGEN3000HC and Tektronix AFG3102C) and an amplifier (Ophir 5084 and Empower 1100) on a custom-printed, 3D-printed mount with spring-loaded probes making contact with the electrode pads and visualized with an inverted microscope through the transparent substrate. Phase shifts and time delays at 48 MHz (for the results in Fig. 5, A and C) were readily achieved in the two-channel Tektronix unit, which uses a common reference oscillator. A blank piece of LN was used to eliminate birefringence through this optically polarizing material.

**Supplementary Materials**

Supplementary material for this article is available at http://advances.sciencemag.org/cgi/content/full/2/7/e1600089/DC1


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